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Aqueous solution-based synthesis and deposition of crystalline In-Ga-Zn-oxide films with an enhanced mobility

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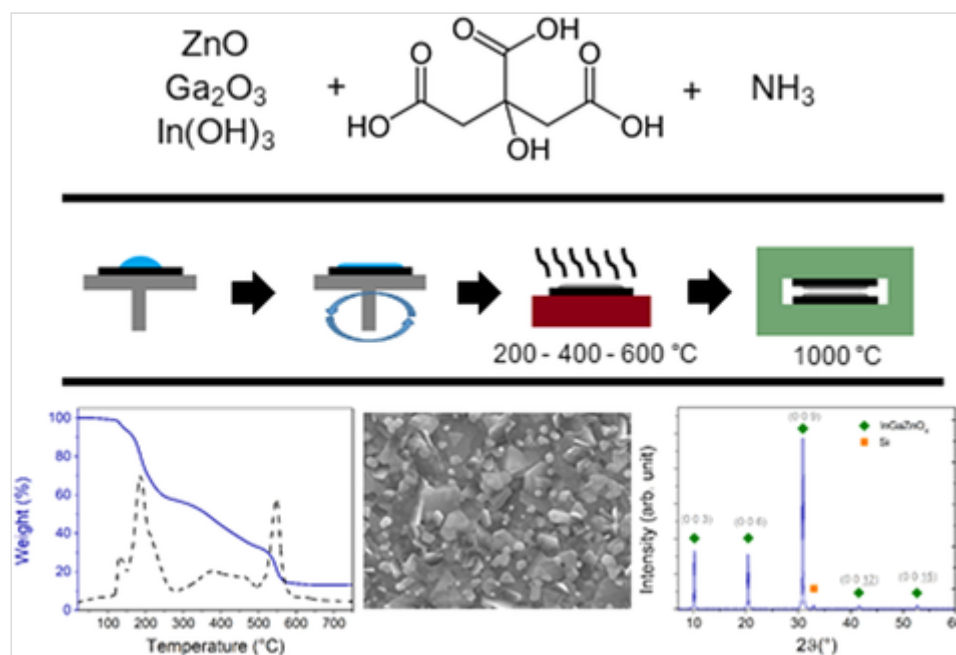
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Abstract

In-Ga-Zn-oxide (IGZO), in its amorphous state, is known to have a high electron mobility and low off-state current inside transistor devices, which may even be further improved by crystallization. Thin films of the IGZO

superlattice structure require an optimal layer homogeneity in addition to precise control of the stoichiometry, which can be achieved by using a solution-based process. In this work, an aqueous precursor system is developed, starting from the respective metal (hydr)oxides. A stable multimetal precursor is obtained, which is ideally suited for solution-deposition via spin-coating. Through an optimized multi-step thermal treatment, crystalline thin films of IGZO are obtained that show a preferential c-axis orientation after rapid-thermal annealing at 1000 °C in inert conditions. The resulting film shows a good optical transparency (>0%) and an improved carrier mobility (27.2 cm²/Vs) compared to typical solution-processed amorphous IGZO films, and is therefore promising for further application.

Top: Overview of the precursor synthesis, which consists of the metal (hydr)oxides as a starting product, citric acid (ligand) and ammonia (pH adjustment and bridging ion). Middle: Schematic route of the film processing. The precursor is applied on a substrate via spincoating. Intermediate hotplate steps (200–400–600 °C) decompose the precursor into an oxide film. Finally, a thermal treatment (1000 °C) inside an RTP (double-substrate setup) crystallizes the oxide films. Bottom: Thermogravimetric plot of the thermal decomposition of the precursor solution // Plane view SEM micrograph of the film morphology after annealing at 1000 °C for 500 s // XRD diffractogram of the film after annealing at 1000 °C for 500 s.



Highlights

- Solution-based deposition starting from an aqueous multimetal citrate precursor system
- Crystalline IGZO films that show a preferential c-axis orientation after annealing at 1000 °C
- An improved carrier mobility compared to typical solution-processed amorphous IGZO films
- A good optical transparency has been observed in the visible-light range

Keywords

IGZO

Sol–gel

Transparent conducting oxide (TCO)

Chemical solution deposition (CSD)

Thermal decomposition

Carrier mobility

1. Introduction

Over the last decades, there has been an increased interest towards oxide-based semiconductor materials for various opto-electronic applications. Especially in display technologies, In-Ga-Zn based oxides (IGZO) are expected to take over the future market which was until recently mostly dominated by silicon (both amorphous and polycrystalline) or organic semiconductors [1]. Much attention has been given to amorphous IGZO (a-IGZO) due to its suitability as a TFT channel material (with carrier mobilities often reaching over 10 cm²/Vs), low off-state current [2] and ease of processing. In order to further improve device performance, crystalline IGZO (c-IGZO, InGaO₃(ZnO)_{*m*}, where *m* is an integer) is a promising candidate which shows even higher carrier mobilities which may lead to an improved device performance [3]. The crystal structure consists of a superlattice, which is already widely reported in literature [4, 5, 6, 7]. Following this concept, epitaxial IGZO layers have been reported, which typically require using single crystalline substrates (such as YSZ, sapphire,..) in combination with a sacrificial ZnO template layer [5, 6, 7, 8]. Despite very high processing temperatures (>1400 °C) and limited substrate options, the fabricated layers showed a greatly improved carrier mobility (>80 cm²/Vs) [9]. The characteristics and properties of polycrystalline (pc) IGZO have not been studied as detailed as their amorphous and epitaxial counterparts. Yet, over the last few years,

nanocrystalline IGZO films, which are often produced with a c-axis alignment (CAAC) and no defined grain boundaries in the a-b plane, have attracted some interest by yielding excellent device characteristics [10, 11]. Therefore, this work attempts to further bridge the gap by investigating the processing steps and opto-electrical properties of pc-IGZO which is deposited via a solution-based route.

Typically, solution deposition of IGZO starts from metal nitrates and/or acetates which are dissolved in 2-methoxyethanol (2-ME) [12, 13, 14, 15, 16], often adding ethanolamine as a stabilizing agent. Despite leading to facile film depositions, 2-ME has harmful and teratogenic properties [17]. One of the features of 2-ME is the rather high dielectric constant of 17 [18], which enables a relatively high solubility of common metal salts.

In this work, water is explored as an environmentally friendly and inexpensive alternative which also benefits from a high polarity and dielectric constant. To this end, an aqueous precursor system is described for thin film deposition via spin-coating, in which the metal ions are stabilized by α -hydroxy carboxylic acids as ligands. These precursor systems also require a careful pH-regulation in order to prevent hydrolysis of the individual metal salts, which is to be avoided. A possible issue with these precursor systems which form amphoteric metal oxides can occur when solution-processing several layers on top of each other. From previous research on ZnO films [19], dissolution of underlying layers was found to take place due to the reactivity of the precursor solution towards the deposited oxide, impeding the increase of the layer thickness. Here we demonstrate that this effect can be minimized by saturating the precursor solution with the starting (hydr)oxide. All of the abovementioned challenges were successfully overcome by optimizing the precursor properties, the solution-deposition process and the post-deposition processing steps. The opto-electrical properties of the resulting films were studied in detail, providing more insight into the effect of crystallization on the behavior of electrical conductivity of the IGZO films.

2. Experimental work

2.1. Precursor synthesis

The individual aqueous metal citrate precursors were synthesized as follows:

In(III) citrato-precursor: $\text{In}(\text{OH})_3$ (Umicore Electro-Optic materials) was dissolved in a concentrated aqueous solution of citric acid (Sigma-Aldrich, 99%; 4:1 molar ratio with the metal ion). The mixture was refluxed for 90 min at 120

°C. After cooling down, the acidity of the solution was lowered by adding aqueous NH_3 -solution (VWR, 32%, GPR Rectapur), while carefully monitoring the pH. The final pH was set at a value of 7. This resulted in a clear, colorless solution.

Zn(II) citrato-precursor: ZnO (Sigma-Aldrich, ACS reagent >99.0%, puriss. p.a.) and citric acid were dissolved in water in a 1:1 molar ratio. The mixture was stirred thoroughly, after which an aqueous NH_3 -solution was added in order to increase the pH towards 7. This resulted in a clear, light yellow solution [19].

Ga(III) citrato-precursor: Ga_2O_3 (Alfa Aesar, 99.99%, metals basis) and citric acid were mixed together in a 1:2 molar ratio, and refluxed overnight (temperature set at 120 °C) after adding a small amount of water. The resulting slurry was dissolved in a NH_3 -solution and was stirred while continuously heating for 72 h. The resulting solution was filtered and the pH was adjusted towards 7 when needed.

For each of the precursors, the solution was saturated by further adding the starting (hydr)oxide beyond the dissolution limit, at which it was stirred for 14 days. Afterwards, the solutions were filtered over a 0.1 μm filter (Pall Supor-100) in order to remove the precipitates.

The individual citrato precursors were combined stoichiometrically in a 1:1:1 metal ratio, after the metal ion concentration was determined by inductively coupled plasma-atomic emission spectroscopy (ICP-AES, Optima 3300, PerkinElmer). The total metal ion concentration in the multimetal precursor was set at 0.42 M. Finally, the precursor was stirred overnight at room temperature and filtered before use (Pall Acrodisc PSF syringe filter, 0.2 μm).

Gels were formed by drying the precursor solution at 80 °C inside a drying stove under atmospheric conditions (Binder ED53). Afterwards, the gel was milled down into a powder for further analysis, using an agate mortar.

2.2. Film deposition and post-deposition processing

Both Si/SiO₂ (200 nm thermal oxide, processed at IMEC, 25 × 25 mm) and fused silica substrates (Neyco, NEGS2, 25 × 25 mm) were pre-treated using an SPM/APM cleaning procedure in order to remove possible organic contaminants and to improve the wetting of the aqueous precursor. Bath 1 (SPM) consisted of a concentrated H_2SO_4 – H_2O_2 mixture, while the second bath (APM) contained a diluted NH_4OH – H_2O_2 mixture. After the cleaning procedure, the samples were stored under aqueous conditions for a maximum period of two weeks.

A stack of multiple IGZO layers was deposited by spin-coating (Polos Spin150i, 3000 rpm, 30 s, 1000 rpm/s) the IGZO precursor on both thermally grown SiO₂ and fused silica. After each layer, the samples were dried and pre-annealed for 2 min on hotplates at 200, 400, and 600 °C under ambient conditions. This process was repeated until the desired film thickness was achieved.

Following the deposition process, the film samples were annealed for 500 s at 1000 °C in a rapid-thermal processor (RTP, Annealsys AS-One 100, 1 °C/s ramp rate). All anneals were performed in a nitrogen atmosphere (Air Liquide, alphagaz) using a flow rate of 1 L/min. A double-substrate setup was used here, in which two samples were stacked with their coated sides facing each other. A similar setup was already proposed in previous literature, when doing high-temperature processing of crystalline IGZO films [5, 6, 7].

2.3. Film and gel characterization

Thermal decomposition of the powdered gel was monitored via thermogravimetric analysis (TGA, TA Instruments Q-500, ramp rate: 10 °C/min) under a dry air flow (90 ml/min). TGA coupled with mass spectroscopy (TG-MS, TA instruments TGA Q5000, Pfeiffer quadrupole MS, High-T Pt sample pan, ramp rate: 10 °C/min) was similarly performed under a dry air flow of 35 ml/min.

The morphology and the layer thicknesses of the processed films were analyzed via scanning electron microscopy (SEM, FEI Quanta 200 FEG). Two imaging modes (SE: secondary electron imaging, BSE: backscattered electron imaging) are used to reveal the morphology (SE) or compositional contrast (BSE). Phase determination of the film samples was done via X-ray diffractometry (XRD, Bruker D8, step size: 0.04°, step time: 3 s). Rocking curve measurements were performed under a 2-theta angle of 31.045°, while the incident angle was varied between 2–30° (step size: 0.04°, step time: 2 s). For the comparative rocking curve measurements, film samples annealed at lower temperatures and with the same post-deposition process as described above were used (with the final temperature varying between 700–900 °C).

Film transparency was measured via UV–Vis spectroscopy (Agilent Cary 5000, UV-Vis-NIR spectrophotometer, range: 200–1200 nm, step size: 1 nm).

Sheet resistance and Hall voltage were determined by 4-point measurements using the Van der Pauw electrode configuration. The different voltages were measured, while applying a constant current ($I = 10$ mA), with a Keithley 4200 SCS parameter analyzer and the sample was mounted in a variable temperature

Lakeshore CPX-VF probe station. For the Hall measurements, the magnetic field was swept between -2 and $+2$ Tesla (with intervals of 0.2 T), perpendicular to the sample surface.

3. Results and discussion

3.1. Precursor synthesis

Metal (hydr)oxides were chosen as starting products instead of the typical nitrate salts used in 2-ME based precursors. By avoiding the addition of nitrates to the precursor solution (leading to NH_4NO_3), the thermal decomposition process will be less violent, which results in an overall improved film quality. Because of the poor solubility in water, citric acid (H_3Cit) was added as a ligand due to its excellent coordinative properties [20, 21].

In literature, structural studies of metal citrate complexes are not uncommon, often due to their biological or medical application. For gallium, the trinuclear complex $[\text{Ga}_3(\text{H}_{-1}\text{Cit})_3(\text{OH})(\text{H}_2\text{O})]^{4-}$ was shown to be dominant for a citrate/metal-ratio of 1:1 under neutral pH conditions [22, 23]. For higher citrate to gallium ratios, as is the case in our study, the typical mononuclear complex is observed in which two fully deprotonated citrate ligands coordinate to the Ga^{3+} center in an octahedral fashion. The tridentate coordination for each citrate anion occurs via two carboxylate groups and the single alkoxy group [24].

For zinc, a complex structure similar to the abovementioned gallium is reported for citrate/metal-ratios of 2:1 and higher [25, 26]. For the 1:1 ratio, the lone citrate will be threefold coordinated, while the remaining coordinative positions are potentially taken up by water molecules. Beyond pH 7, the dinuclear $[\text{Zn}_2(\text{H}_{-1}\text{Cit})_2]^{4-}$ was observed as significant species in solution [27, 28].

For indium, it has been reported that for low citrate to metal ratios there are multiple equilibria at play, which typically result in polynuclear complexes [29]. For high citrate to metal ratios, each In^{3+} center is coordinated by 3 bidentate citrato ligands, resulting in the octahedrally coordinated $[\text{In}(\text{Cit})_2(\text{H}_{-1}\text{Cit})]^{7-}$ at neutral pH values [29].

At neutral pH, this resulted in stable metal citrate complexes, although an excess of ligand was typically needed in order to easily achieve full dissolution. A great advantage to this route is that the individual metal citrate precursors are easily combined, since there are no pH variations and no counterions present (besides NH_4^+), which can disturb the chemical equilibria and the stability of the citrate complexes.

During the initial drying and heating of the precursor solution, the NH_4^+ ions (which were introduced during the pH adjustment) will also take up the role of bridging ions between the individual citrate complexes. This way, a network is formed, leading to a stable and uniform precursor gel [21].

3.2. Thermal decomposition of the precursor gel

The thermal decomposition of the precursor gel under dry air atmosphere takes place in four steps: region I (100–160 °C), region II (160–270 °C), region III (270–500 °C), and region IV (500–600 °C). The full decomposition profile can be seen in Fig. 1 and an overview of the evolved mass fragments are given below in Fig. 2 and Table 1 [19, 30, 31].

Fig. 1

Thermogravimetric analysis of the decomposition of the IGZO-precursor gel dried at 80 °C. Both the decomposition profile (solid line) and the first derivative curve (dashed line) are given

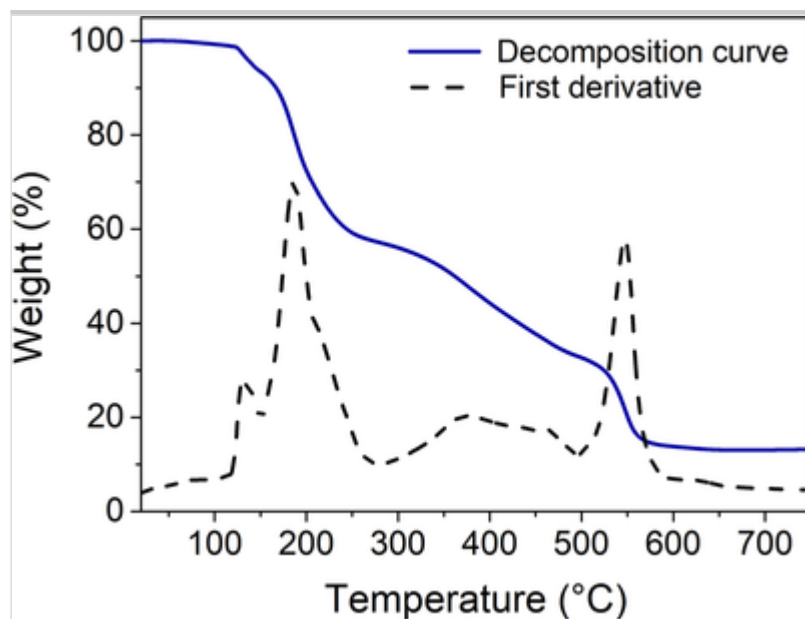


Fig. 2

TG-MS ion currents for the decomposition related m/z values (color legend on the right), detected during the same thermal profile as illustrated in Fig. 1 (color figure online)

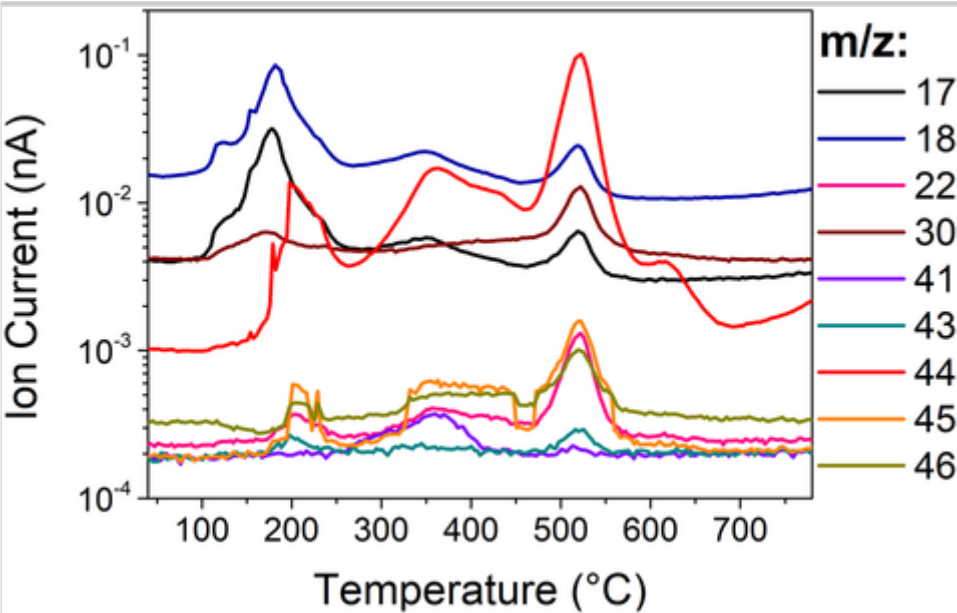


Table 1

Evolved gas analysis overview, presenting the detected mass fragment ions for each decomposition step

	Temperature range (°C)	Evolved fragments (<i>TG-MS m/e</i>)
Region I	100–160	OH, NH ₃ (17) – H ₂ O (18) – NO (30) ^a
Region II	180–270	OH, NH ₃ (17) – H ₂ O (18) – CO ₂ (22, 44, 45) – CH ₂ NH ₂ , NO (30) – HNCO (43) – COOH (45) – NO ₂ (46)
Region III	270–500	OH, NH ₃ (17) – H ₂ O (18) – CO ₂ (22, 44, 45) – CH ₂ NH ₂ , NO (30) – CH ₂ CCNH (41) – COOH (45) – NO ₂ (46)
Region IV	500–600	OH, NH ₃ (17) – H ₂ O (18) – CO ₂ (22, 44, 45) – CH ₂ NH ₂ , NO (30) – CH ₃ C=O (43) – COOH (45) – NO ₂ (46)
^a Tentative assignment		

In the first decomposition region (<160 °C), most mass loss originates from the evaporation of residual H₂O, together with NH₃ evolution coming from the considerable amount of ammonium citrate present in the precursor system. Ammonia evolution continues until the end of region II (260–270 °C), which results in the formation of residual amides and/or imides which will typically decompose above 300 °C [30]. An additional source of H₂O evolution can be detected in region II, where the dehydroxylation of ammonium citrate occurs. This is combined with a sharp onset of the *m/z* = 44 signal around 175 °C (and a second maximum at 200 °C), where the strong CO₂ signal can be ascribed to the citrate decarboxylation reaction. For the Zn-citrate precursor complex, it could

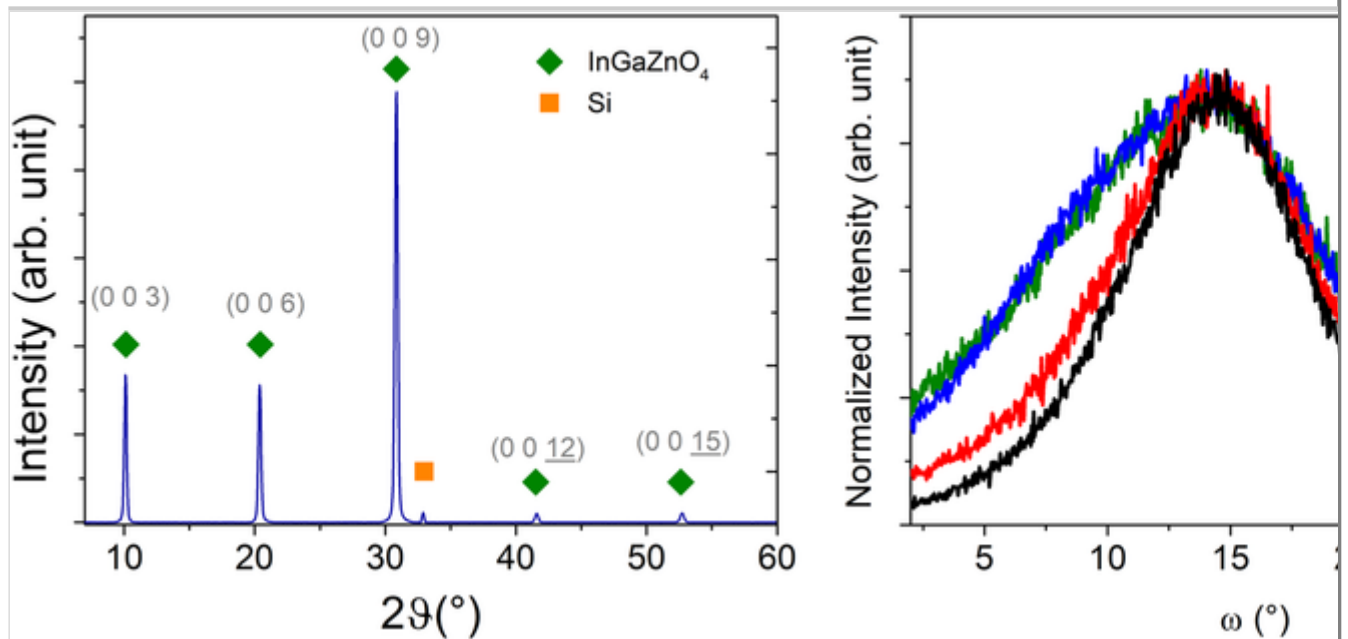
clearly be observed that the dehydroxylation and subsequent decarboxylation of the ligands [30] take place at temperatures near 340 °C, corresponding to decomposition region III for our system. Since the precursor in this work is a multimetal system, there will be a temperature spread over which the three (or possibly more) individual metal complexes will start to lose their ligand coordination sphere. For our precursor, this gradual process takes place between 330 and 445 °C, with a decarboxylation maximum at 360 °C. During this process, it can be assumed that the oxide formation starts, even though there still is a significant amount of residual fraction (around 20% of the total weight) to be decomposed in the final step. This step consists of the oxidative decomposition, involving oxygen from the applied gas, forming high amounts of CO₂, NO_x, and H₂O alongside some organic backbone fragments. The system is fully decomposed at a temperature of 600 °C with a residual weight of 12.9%.

3.3. Phase formation

XRD experiments demonstrate that the film crystallinity increases drastically with annealing temperature, starting from around 700 °C. Figure 3 (left) shows the individual θ – 2θ XRD-diffractogram for a 1000 °C annealed sample (reference: PDF nr. 00-038-1104, rhombohedral, R-3m). No intermediate or secondary phases could be detected, other than the presence of the Si substrate peak at 32.9°. The resulting film is phase-pure within the detection limits of the method and shows a strong intensity for the (0 0 *n*)-lattice diffractions, which correspond with the c-axis of the IGZO superlattice. Rocking curve analysis was performed on samples annealed between 700 and 1000 °C, selecting the most intense diffraction peak (0 0 9) at a 2θ angle of 30.84°. The peak maxima were normalized in order to compare peak width. As can be seen in Fig. 3 (right), the peak width decreases with increasing temperature. This confirms a larger degree of preferential c-axis orientation after annealing at higher *T*.

Fig. 3

Left: XRD diffractogram of an IGZO film sample (*m* = 1) annealed at 1000 °C for 500 s (IGZO reference: PDF nr. 00-038-1104). Right: Rocking curve analysis of the most intense diffraction peak as a function of increasing annealing temperature

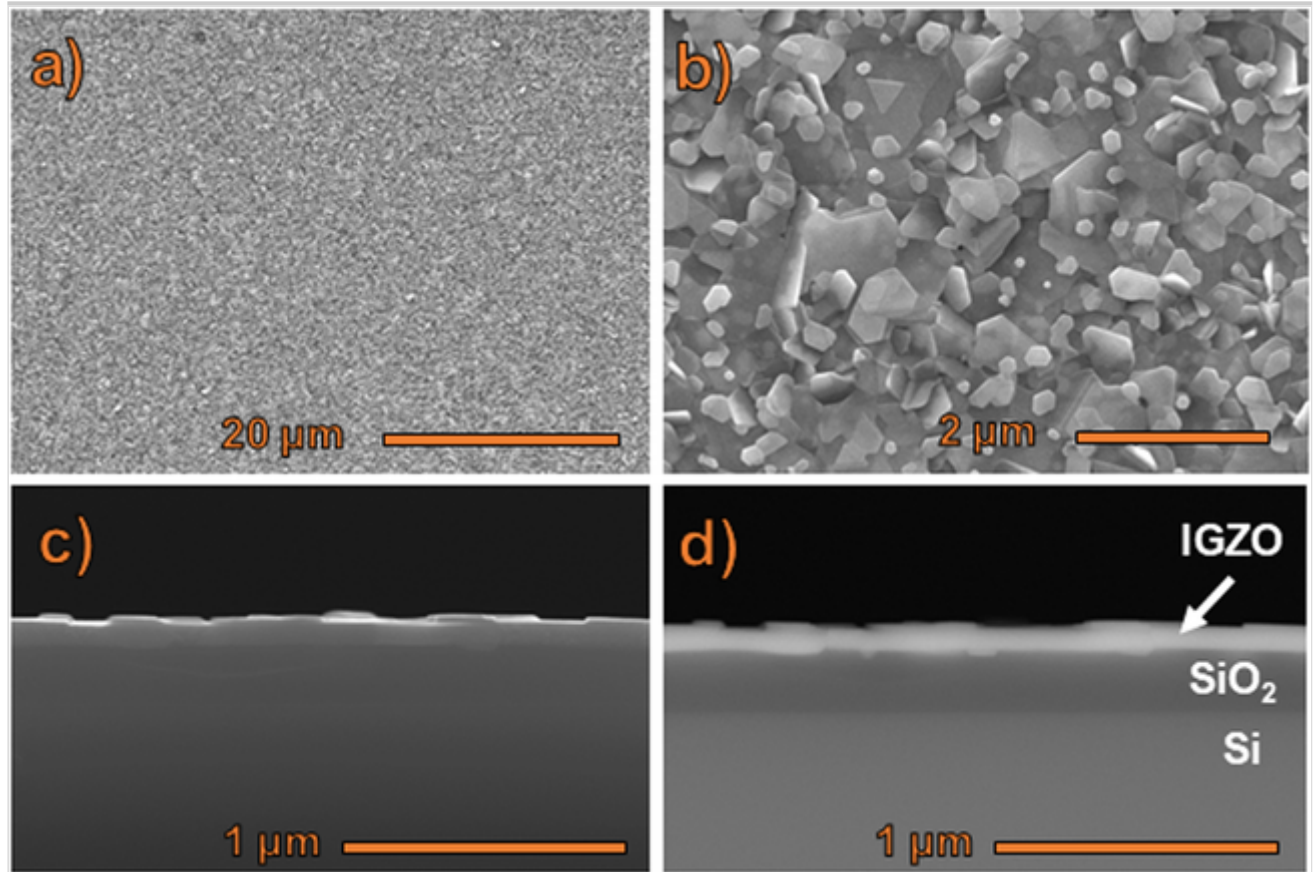


3.4. Film morphology

The film morphology and thickness after annealing at 1000 °C were visualized via SEM in both plane view (Fig. 4a, b) and cross-sectional mode (Fig. 4c, d). Even though the film has a visually smooth and shiny surface, it shows a rough microstructure with well-defined crystal grains. The grains have a plate-like morphology and are mostly hexagonal or trigonal in shape, which corresponds to the nature of the lattice type. Their lateral sizes vary, with diameters ranging between 100 nm and several micrometers. The bigger grains are typically oriented parallel to the surface, which corresponds with the observations made by XRD-analysis where a strong c-axis orientation could be observed. Even though there is a strong overlap of the plate-like grains, the film cross-section shows a relatively uniform and homogeneous layer with an average thickness of 96 nm. For the cross-sectional case, the backscatter electron micrograph (Fig. 4d) is included to improve the visualization of the layer homogeneity and thickness.

Fig. 4

a, b Plane view secondary electron SEM micrographs of an IGZO thin film deposited using five spincoated layers and annealed at 1000 °C for 500 s, at two magnifications. **c, d** Secondary electron and backscattered electron SEM image of the film's cross section

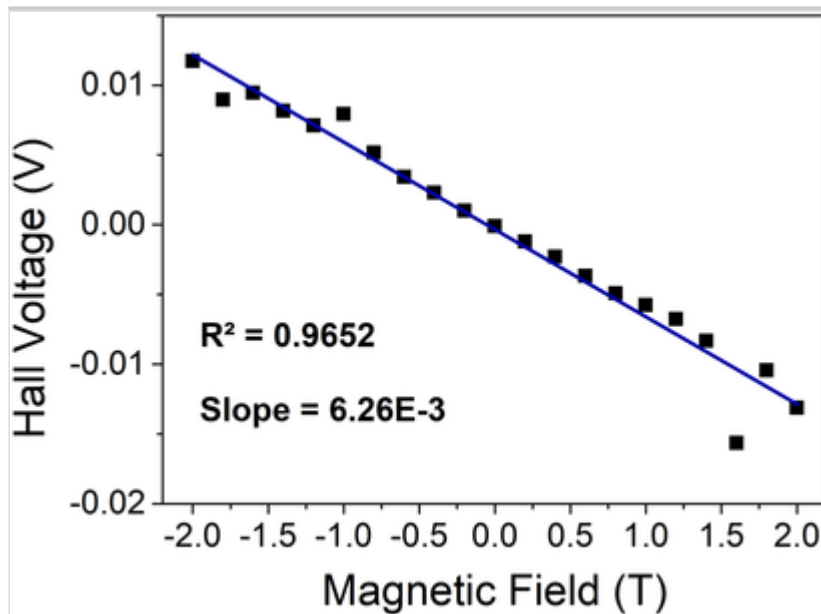


3.5. Electrical properties

The Hall voltage (V_H) was measured under a sweeping magnetic field. The resulting data points are shown in Fig. 5 and were fitted with a straight line ($R^2 = 0.9652$), yielding a slope (V_H/B) of 6.26×10^{-3} V/T. From this value, we could calculate a charge carrier concentration of $9.98 \times 10^{19} \text{ cm}^{-3}$ and a Hall mobility of $27.2 \text{ cm}^2/\text{Vs}$. In addition, the resistivity of the sample was measured to be $2.3 \times 10^{-3} \Omega \text{ cm}$.

Fig. 5

V_H vs. B -plot of the IGZO film sample annealed at 1000°C , measured using a Van der Pauw contact configuration ($I = 10 \text{ mA}$). The data was fitted with a straight line and the slope was extracted



Hosono et al. identified the role of the conduction band minimum (CBM), which is localized on the metal s-orbitals, towards the conduction mechanism of IGZO [32, 33]. Since the s-orbitals of these heavy metal ions are relatively big and show no spacial directionality due to their spherical nature, a large orbital overlap (even in the amorphous state) can be expected, leading to a higher band dispersion and improved carrier mobility. This theory is of course supported by the successful application of a-IGZO inside TFTs. For polycrystalline IGZO films, however, there will be a negative effect of the many grain boundaries on the conduction pathway efficiency, since it disrupts the metal s-orbital overlap and increases the amount of scattering sites. Despite this fact, we can still observe a relatively high carrier mobility compared to typical IGZO layers, of which selected literature values are summarized below (Table 2). It can therefore be assumed that the densification and periodic stacking of the metal ions within the crystal lattice of the grains improves the s-orbital overlap, leading to an overall lower electron effective mass and higher mobility. Another possible hypothesis for this high mobility, despite the presence of grain boundaries, is the following: Due to the strong preferential c-axis orientation, adjacent grains show an improved alignment which may facilitate inter-grain transport of charge carriers throughout the film. In a way, this describes the IGZO-phase discussed in this work as an intermediate state between polycrystalline IGZO (random orientation, low mobility) and epitaxial/single crystalline IGZO (perfect c-axis orientation, very high mobility). Along this line, the c-axis aligned IGZO layers which show promising mobility values in literature, can be placed in the latter category. It must be noted however, that mobility values retrieved from other studies are typically measured from FET devices, and are therefore often reported as field-effect mobilities.

Table 2

Overview and comparison of selected literature sources with their reported carrier mobility values

AQ1

Degree of crystallization	Deposition method	Temperature (°C)	Carrier mobility* (cm ² /Vs)	Reference
(a)				
Polycrystalline	Nanoparticle solution (H ₂ O)	95	2.3	[34]
Amorphous	Solution-based (2-ME)	450	6.23	[35]
Amorphous	Solution-based (2-ME)	600	6.415	[12]

Part (a) of the table corresponds to solution-processed samples

Degree of crystallization	Deposition method	Temperature (°C)	Carrier mobility* (cm ² /Vs)	Reference
Amorphous	Solution-based (2-ME) + pulsed UV-light	350	7	[36]
Amorphous	Solution-based (H ₂ O)	250	7.73	[37]
Amorphous	Solution-based (H ₂ O)	300	7.9	[38]
Amorphous	Solution-based (2-ME)	350–500	20–30	[15]
Polycrystalline	Solution-based (H ₂ O)	1000	27.2	This work
Amorphous	Solution-based (2-ME)	300	20–50	[14]
(b)				
CAAC	DC sputtering	300	7.3	[39]
Polycrystalline	RF-magnetron sputtering	950	14.7	[3]
Amorphous	RF-magnetron sputtering	450	15.8	[40]
Amorphous	RF-magnetron sputtering + UV-thermal treatment	150	16.2	[41]
Amorphous	RF-magnetron sputtering	300	17.4	[42]
Amorphous + CAAC dual layer	RF-magnetron sputtering	310	20.6	[43]
Amorphous	RF-magnetron sputtering + laser spike	430	73.5	[44]

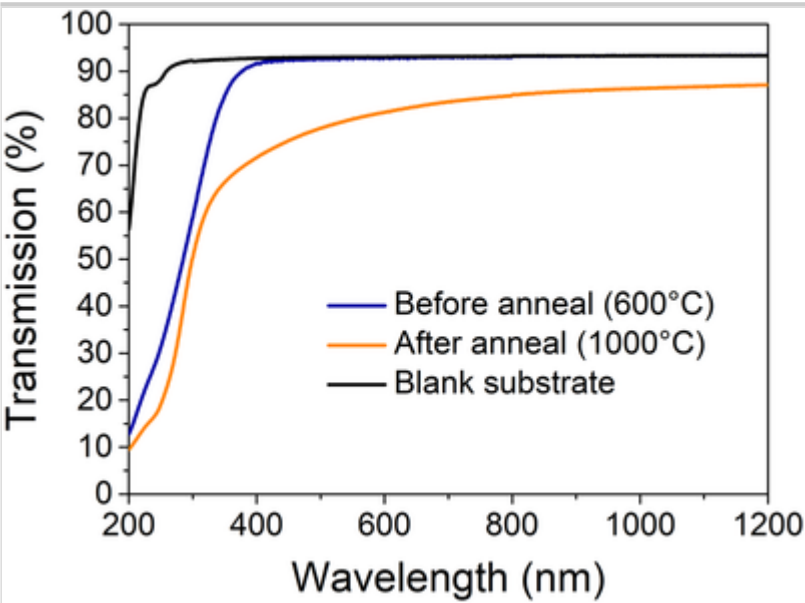
	annealing			
Single-crystalline	Pulsed laser deposition	1400	80	[9]
Part (a) of the table corresponds to solution-processed samples				

3.6. Optical properties

The optical transparency of the IGZO film was investigated by depositing a layer of equal thickness on a fused silica substrate followed by annealing at 1000 °C (Fig. 6). The blank substrate showed a transparency of 93% in the visible light range (with air used as a background). The IGZO film on fused silica showed a similar transparency in the amorphous state (600 °C). After annealing at 1000 °C, the visible-light transparency decreases slightly towards values between 71.6% (400 nm) and 85.0% (800 nm). This loss in transparency can be explained by the increase of sample roughness due to grain formation, as seen in the SEM results. This results in a larger degree of scattering at the grain boundaries, which decreases the specular transmittance.

Fig. 6

UV-Vis-NIR transmission spectra of the IGZO film vs. air, before and after annealing. The blank spectrum for the fused silica substrate is provided as a reference



4. Conclusions

A polycrystalline rhombohedral IGZO film with a preferential c-axis orientation was obtained by solution-deposition, starting from a stable aqueous multimetal

citrate precursor system. We hereby provide a safe and sustainable alternative to 2-ME based precursors, which additionally often contain nitrates. After careful tuning of the processing steps, the study shows that at the cost of a higher thermal budget and a slightly increased surface roughness, a significant gain in carrier mobility compared to typical solution-processed amorphous IGZO films can be achieved. This result suggests that, despite the abundant presence of grain boundaries inside the film, a dense and periodic stacking of the metal ions inside the lattice is highly beneficial towards an overall increase of the electron mobility throughout the conduction pathway. The logical next step is the implementation of these polycrystalline IGZO layers in devices in order to further quantify and compare their performance versus the more commonly studied a-IGZO layers.

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Compliance with ethical standards

Conflict of interest The authors declare that they have no conflict of interest.

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